



H&A-104

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

K. NAGATA et al

Serial No. 09/924,575

Group Art Unit: 2881

Filed: August 9, 2001

Examiner: L. Nguyen

For: METHOD AND APPARATUS FOR CHARGED
PARTICLE BEAM EXPOSURE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed November 6, 2003,
please amend the above-identified application as follows.

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